



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Kiyoshi IRINO**

Group Art Unit: **2815**

Serial No.: **09/428,052**

Examiner: **Jose R. Diaz**

Filed: **October 27, 1999**

Confirmation No.: **4139**

For: **METHOD OF FABRICATING A SEMICONDUCTOR DEVICE  
CONTAINING NITROGEN IN A GATE-OXIDE FILM (As  
Amended)**

Attorney Docket Number: **970901A**

Customer Number: **38834**

**PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Date: February 9, 2005

Sir:

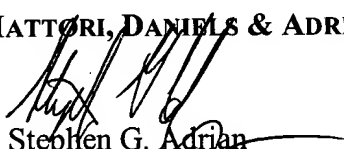
Applicant petitions the Commissioner for Patents to extend the time for response to the Office Action dated September 9, 2004 for two months from December 9, 2004 to February 9, 2005.

Attached please find a check in the amount of \$450.00 to cover the cost of the extension.

If any additional fees are due in connection with this paper, please charge our Deposit Account No. 50-2866.

Respectfully submitted,

**WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP**

  
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